

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Schulze, *et al.* Attorney Docket: 2002P50544US
Filed: January 8, 2004 Examiner: TBD
Serial No.: 10/753,604 Art Unit: 1762
Title: Method for the Repair of Defects in Photolithographic Masks for Patterning
Semiconductor Wafers

Commissioner for Patents
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Associate Power of Attorney

I hereby appoint as associate attorneys of record all of the attorneys and agents at
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Respectfully submitted,


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